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Typed or Printed Name of Person Mailing Paper or Fee: Patricia Aguillon

Signature: Patricia Aguillon

PATENT
Docket No. P1573

**IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT: JENNIFER WANG

SERIAL NO.: 10/782,538 EXAMINER: UNKNOWN

FILED: FEBRUARY 18, 2004 ART UNIT: 1763

FOR: METHOD OF DRY PLASMA ETCHING SEMICONDUCTOR
MATERIALS

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

TRANSMITTAL LETTER

Dear Sir:

In connection with the above-referenced patent application, transmitted herewith are the following:

1. Status Inquiry Letter (1 page); and
2. Post card in acknowledgment of receipt of all transmitted materials.

Please date stamp and return the enclosed post card to the undersigned in acknowledgment of receipt of all transmitted materials.

Respectfully submitted,

A handwritten signature in cursive script, reading "May Lin DeHaan".

May Lin DeHaan
Reg. No. 42,472

MLD/pa
Date: March 16, 2005
LARIVIERE, GRUBMAN & PAYNE, LLP
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STATUS INQUIRY LETTER

Dear Sir:

Please advise as to the status of this application. In particular, please inform us as to when the Examiner expects to take this case up for action. The most recent document received from the Patent Office is the Updated Filing Receipt dated July 28, 2004.

Respectfully submitted,

May Lin DeHaan

May Lin DeHaan

Reg. No. 42,472

MLD/pa
Date: March 16, 2005
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